SrTiO₃ surface micro-structuring with swift heavy ions in grazing incidence geometry

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Abstract :

In this work, we present first experimental results on the micro-structuration of monocrystalline strontium titanate (100)-SrTiO₃. A self-organized structure appears on its surface due to irradiation with 0.71 MeV/u ¹²⁹Xe²³⁺ and 0.55 MeV/u ¹³⁶Xe¹⁹⁺ swift heavy ions at room temperature and under grazing incidence. The resulting wave-like structure appears normal to the direction of the ion beam. X-ray diffraction (XRD) and transmission electron microscopy (TEM) analyses were undertaken to probe microstructural properties below the surface, revealing in particular surface amorphization at high fluences. Such amorphous surface layers, further irradiated at high fluences, may lead to an anisotropic plastic deformation (hammering) effect, inducing the observed self-organized structure due to the grazing angle configuration. This surface morphology was characterized by atomic force microscopy (AFM). A dependency of the periodicity as well as the width of the undulations on the irradiation parameters, the characteristics of these patterns can be controlled and thus opens the possibilities for custom surface structuration.

Keywords:

SrTiO₃, Ripples, Swift heavy ions, Grazing angle, micro-structuring

1. Introduction

1 During the irradiation of solid materials with charged ions, an energy transfer takes place 2 from the projectile to the target material throughout its trajectory and following different interactions. Two main processes can describe this energy transfer from the projectile to the 3 target. Elastic collisions linked to nuclear shock, i.e. the projectile interacts mainly with the 4 5 nucleus of the target atom and thus the nuclear stopping power dominates for low projectile 6 velocities. Inelastic collisions, which involve the electronic system of the target and induce an 7 electronic stopping power, prevail for high projectile velocity i.e. an ion energy greater than 8 0.1 MeV/u. Modifications of the target can thus result from these multiple interactions and energy exchanges, depending on the nature of the material and the energy of the projectile. In 9 10 the current article, ions of energy higher than 0.1 MeV/u are used where projectiles are known as swift heavy ions (SHI). Irradiation in this energy range i.e. for ions with a kinetic energy in 11 the MeV-GeV range and above has been the subject of various studies under different 12 13 conditions and for different types of materials in the last years. These irradiations lead to permanent structural modifications such as defect formation or even amorphization. For 14 individual ion impacts, nano-structures appear at the surface, in the form of nano-hillocks, 15 16 craters as well as chains of nano-hillocks [1-4].

17 Several studies have been carried out to describe the process behind these structural 18 modifications and the energy transfer that occurs. A relatively successful approach based on 19 the heat transport equations has been used to explain the track formation in insulators, namely 20 the thermal spike model [5-6] and then a generalization to other materials has been developed

[7-9]. In the two-temperature model [10], the energy of the projectile is initially locally 1 2 deposited in the electronic subsystem and subsequently transferred to the atoms by electronatom interactions. Until now, this model explains fairly well the track formation in the bulk. 3 However, irradiations with swift heavy ions with a grazing incident angle geometry create 4 different modifications, as the aforementioned chains of nano-hillocks [11-12]. Due to the 5 missing radial symmetry along the ion path and the implication of the electronic structure in 6 the creation of these chains, the standard thermal spike model has been modified, taking into 7 account the non-homogeneous nature of the electron density [2]. 8

9 These material modifications at the surface as well as in the bulk are important because of their technological relevance, and depend strongly on the materials. In many solids, and with 10 a certain stopping power threshold, which differs from one material to another, the energy 11 12 deposited by the SHI around its trajectory can generate an amorphous cylinder, more commonly called an ion track or latent track. As in the case of the strontium titanate (SrTiO₃) 13 where for an irradiation at low fluences, i.e. in the individual ion impact regime, for a normal 14 incidence angle, each ion induces the formation of hillock like structure on the surface and an 15 amorphous track surrounded by a disordered crystalline area in the bulk. By changing the 16 angle of irradiation towards grazing angles, a chain of nano-hillocks is obtained on the 17 surface, and a relatively straight track in the bulk. However, in the multiple ion impact 18 regime, i.e. for fluences high enough to have an overlapping of the ion tracks, a surface 19 amorphization is induced for an irradiation at normal angle of incidence with the appearance 20 21 of an amorphous layer having a thickness of a few micrometers [13]. The main goal of the present contribution is to explore the response of the surface of SrTiO₃ to irradiation with SHI 22 23 by combining high fluence and grazing angle of incidence.

Surface nano- and micro-patterning is important and gaining popularity, especially in the fabrication of periodic patterns like waves with controllable characteristics, which is useful in modeling and adapting a material for different technological purposes. The first observation of periodic structures was made by Navez *et al* in 1962 after ion bombardment of a glass sample at low energy [14]. At large incident angles close to the surface normal direction, ripple patterns with ridges oriented perpendicular to the beam direction are created. The distance between these periodic patterns decreases as the angle of incidence increases toward the normal to the surface.

7 Studies have intensified in the following years, focusing mainly on the creation of these periodic waves by irradiation with low energy ions, i.e. an energy below 10 keV/u, on 8 different types of materials such as metals [15], insulators, or semiconductors [16-18]. 9 10 Considering nuclear collisions and sputtering as the main processes inducing modifications at low energy, the formation of these periodic structures on the surface results directly from a 11 combination of the roughening effect due to removal of surface material and smoothing 12 (which may be due to ion induced diffusion or viscous flow for amorphous surfaces). Studies 13 at high and medium energy are less numerous. The first observation of dimensional changes 14 15 induced by SHI irradiation was reported by Klaumünzer et al [19-20] for metallic glasses, 16 where an anisotropic growth of the sample was observed, appearing as a swelling in the dimensions perpendicular to the ion beam and a contraction in the dimension parallel to it, 17 18 such effect increases with the electronic energy loss. Several studies have followed with other amorphous metallic and non-metallic alloys and all have shown the same behavior, with the 19 production of disorder and defects followed by an anisotropic deformation of the sample 20 dimensions. This so-called "hammering effect" was explained [21] by the shear stress 21 22 generated by the thermal expansion of the cylindrical thermal spike around the ion trajectory, 23 followed by the relaxation of this stress within the molten phase, and then the freezing-in of the associated strain increment during the subsequent cooling-down process. The "hammering 24 effect" was also invoked to explain the development of periodic nano-patterns and lamella 25

structures observed under SHI for off-normal irradiations in the case of oxide thin film 1 2 systems, like NiO deposited on SiO₂ [22] and on other different substrates [23], where they 3 appear at the beginning of the irradiation in the form of cracks perpendicular to the ion beam direction. Then by increasing the fluence, these cracks form periodic patterns whose width 4 decreases with an increase in the periodicity as the fluence is increased, forming thus the 5 pattern known as ripples. Different halide thin films were also investigated like LiF and BaF₂ 6 7 deposited onto glass substrates and maintained at the temperature of liquid nitrogen during the irradiation. Different fluences were used at an angle of incidence of less than 15° with respect 8 to the sample surface and where SHI induced surface reorganization into lamella structures 9 10 was observed, but not for those irradiated at room temperature [24]. The different 11 technological applications offered by this ion-induced surface nano-structuring are becoming more and more interesting. An application of these ripples is considered in the case of thin 12 film deposition, or for the manufacture of micro and optoelectronic devices. [25-26]. 13

The aim of this paper is to present first experimental results on the modification, structural 14 15 and morphological evolution of the surface of strontium titanate single crystals irradiated by swift heavy ions at various grazing angles of incidence. Although our samples are not thin 16 layers deposited on substrates of different natures, and thus the irradiation conditions differ 17 18 from the previous reported studies, we find that periodic patterns like ripples also develop at the surface of our single crystals. The different experimental parameters like the incident 19 angle of the projectile and the ion fluence appear to control the characteristics of this surface 20 micro-patterning and can therefore be tuned according to the application needs. An attempt to 21 22 understand the mechanism is also suggested.

23

2. Experimental

For our experiments, single-crystal samples of (100)- SrTiO₃ from Crystec company (Berlin),
 were irradiated at room temperature under vacuum on atomically clean surfaces.

The swift heavy ion irradiation experiments were performed at the GANIL (Grand 3 4 Accélérateur National d'Ions Lourds - France, Caen) facility, at the IRRSUD beam line with 92 MeV ¹²⁹Xe²³⁺ and 75 MeV ¹³⁶Xe¹⁹⁺. It corresponds mainly to an electronic energy loss at 5 the surface (calculated with the SRIM code [27] with the density of 5.117 g/cm⁻³) of 21 6 7 keV/nm and 19 keV/nm respectively, well above the stopping power threshold needed for track formation of 12 keV/nm [13]. On the contrary, the nuclear energy loss is very small at 8 the surface, being around 0.18 keV/nm, and 0.22 respectively, and increases slightly inside 9 10 the bulk up to a maximum at the projected range of $\sim 8 \,\mu\text{m}$. Different angles of incidence with respect to the surface were used, ranging from $\theta = 0.5^{\circ}$ (grazing incidence) up to 90° (normal 11 incidence). The fluences were chosen in such a way to have individual ion impact up multiple 12 overlapping ion impact regions, by using ion fluxes low enough to avoid macroscopic sample 13 heating. 14

15 After irradiation, the samples were analyzed ex-situ using atomic force microscopy (AFM) with a Park system Nx10 under ambient conditions in tapping and non-contact mode. The 16 AFM images were processed with the Gwyddion software package [28]. X-Ray diffraction 17 was carried out with a high-resolution Bruker D8 Discover diffractometer. A Cu X-ray 18 source, a Göbel mirror and an asymmetric Ge monochromator are used as primary optics 19 getting a wavelength $\lambda_{k\alpha l} = 0.154056$ nm, while a 1D LYNXEYE is used for the detection. A 20 symmetric geometry was used to record 2θ - ω patterns implying a varying probed material 21 depth as function of the diffraction angle of around $8.14 \pm 0.0015 \,\mu\text{m}$ for the (200) reflection 22 recorded at 46.44°. Electron-transparent cross-sections were extracted using focused ion beam 23 instrument Helios Nanolab 660 with Ga⁺ ions accelerated at 30 keV (decreased gradually 24 down to 1 keV for the final step). Transmission Electron Microscope (TEM) observations 25

were carried out with a JEOL F200 electron microscope operating at 200 kV equipped with a
 cold field emission gun.

3

3. Results and discussion

SrTiO₃ bulk is known to be an amorphizable material by swift heavy ion irradiation [29]. At 4 low fluence and for a stopping power above a threshold of 12 keV/nm [13], each ion creates 5 an individual amorphous cylindrical track along its trajectory in the bulk that partially extends 6 to the surface. For grazing incidence irradiations, this modification gives rise to the formation 7 8 of a chain of hillocks as often reported by AFM analysis [2]. These chains of nano-hillocks 9 were also observed by electron microscopy as illustrated in Fig. 1a. To go further in the 10 examination of these structures, TEM lamellae were prepared at the precise location of a 11 chain of nano-hillocks using our SEM/FIB facility. The observations made by TEM show the ion tracks induced beneath the surface in the bulk by an irradiation at grazing angles. In Fig. 12 1b a straight track is observed for an irradiation at 3.7° while a non-homogenous effect with a 13 fragmented track is observed for an irradiation at 0.5° (Fig. 1c). This effect can be explained 14 in a similar fashion as for the formation of the chains of nano-hillocks observed on the surface 15 of SrTiO₃ irradiated at grazing incidence [2]. As the surface of a single crystal SrTiO₃ 16 oriented along the (100) direction is considered, and due to its crystalline structure that 17 alternates two different types of atomic planes (Ti-O and Sr-O layers distant from each other 18 19 by 0.2 nm), irradiation with different grazing angles involves thus a different electron density depending on the traversed region of the crystal. During a SHI irradiation, the incident ion 20 will cross along its trajectory the Ti-O crystalline plane containing the highest electron density 21 inducing a greater energy loss every ~ 60 nm in the case of the nominal angle of 0.5° and 22 every ~6 nm for the nominal angle of 3.7° with respect to the surface. As the deposited energy 23 is directly related to the electron density, we therefore expect in the first case the formation of 24 well-separated amorphous spheroids with a radius of the order of that obtained in the 25

cylindrical tracks, i.e. ~ 2,4 nm, while in the second case these spheroids will join to create a
quasi-continuous track. The morphology of these tracks or damaged area can thus differ from
one angle to another. Moreover, a careful examination of the TEM image obtained in the case
of the nominal irradiation at 0.5° (see Fig. 1c) gives an average spacing between spheroids of
about 44 nm, indicating that the actual angle of incidence is ~ 0.35° which is consistent with
our estimated angular uncertainty of 0.2°.

7 On Fig 1b and 1c, density contrasts are also noticed around the tracks corresponding to deformation field in the crystalline matrix surrounding the tracks, reminding the observations 8 done for SrTiO₃ irradiated at normal incidence [13, 29]. Considering the reported track radius 9 10 of 2.4 ± 0.4 nm, the amorphous tracks will overlap as the irradiation progresses giving then rise to a total amorphization of the sample surface for fluences higher than a few 10^{13} 11 ions/cm². In order to study the structural evolution of SrTiO₃ at high fluences but this time in 12 grazing angle geometry, X-Ray diffraction pattern of (200) reflection of SrTiO₃ irradiated 13 with 75 MeV Xe at 6° with 8×10^{13} ions/cm² is compared to a non-irradiated one in figure 2. 14 For a probing depth of $\sim 8 \mu m$, thanks to the X-Ray diffraction geometry, corresponding to 15 16 the irradiated material and well deeper into the non-irradiated material, the intensity of the diffracted signal of (200) reflection is decreased compared to the non-irradiated sample. This 17 18 means that a loss of crystallinity of the initial perovskite structure occurs. It is due to crystal disordering induced by irradiation and surface amorphization. Furthermore, a large 19 broadening on 2O axis extended towards low diffraction angles is observed, which is due to 20 an important tensile strain induced by irradiation [29]. To confirm the formation of an 21 amorphous layer on the surface as in the case of an irradiation at 90° [13], TEM images of a 22 23 cross section prepared by FIB on the same sample as the above analyzed by X-Ray diffraction is shown in Fig. 3. Different visible contrasts indicating different regions of the sample are 24 observed. On the right, the selected area electron diffraction pattern (SAD) taken from the 25

first region along the ion path, i.e. near the surface, clearly indicates by the observation of 1 2 only a diffuse ring the amorphization of the crystal by the incident ions. The thickness of this amorphous layer extending from the surface is around 1.0 µm. Below this layer and deeper in 3 the material, disorder and partial amorphization are observed, which are confirmed in the 4 middle diffraction pattern by a diffuse ring with bright spots. At larger depth, a region where 5 the material remains single crystalline is observed as shown by the last diffraction pattern. 6 7 Although we tend to have the same structural changes at high fluences regardless of the irradiation geometry, at grazing angle the thickness of the amorphous layer is smaller than for 8 an irradiation normal to the surface due to geometrical aspects. These results also confirm that 9 10 strain in the defective crystalline layer localized beneath the amorphous layer also occurs at 11 grazing angle incidence, as the one known at normal incidence. Taking into consideration the localized energy deposition of SHIs in the target and the thin amorphous layer developed on 12 13 the surface, one can assume a resulting surface effect. This is why the main objective through this study is to investigate by means of AFM measurements the response of the SrTiO₃ 14 15 surface to SHI irradiation. Variations of the grazing angles and the high fluence values are applied to explore the SHI induced surface structuring of a single crystalline insulator and to 16 monitor the evolution of the microstructures formed on its surface. 17

Figure 4 shows AFM images of (100)-SrTiO₃ before and after irradiation where (a) represents a typical sample surface before irradiation with an inset showing a scan where the size was chosen to have a resolution where the atomic steps are visible indicating the good resolution of our AFM measurements. In addition, the root mean square (rms) value of the surface roughness is 0.4 nm, proving that the surface is indeed clean and flat without prior surface treatment. Fig.4 (b) represents a sample irradiated with 1×10^{14} ions/cm² at an incident angle $\theta = 7^{\circ}$ with respect to the surface. Here a modification and reorganization of the surface can be observed. This transformation appears in the form of quasi-periodic patterns like waves at
 the microscopic scale.

In order to investigate the formation process and the evolution of these micro-ripple patterns, 3 4 several SHI irradiations were performed at various grazing angles of incidence on a series of samples by varying the fluences ranging from 3×10^{13} to 4×10^{14} ions/cm² and angles of 5 incidence from 2° up to 45° with respect to the surface. Topography examinations of different 6 7 irradiated samples were performed by means of AFM analysis. Figure 5(a) shows a (100)-SrTiO₃ sample irradiated at a fluence $\phi = 9 \times 10^{13}$ ions/cm² and an angle $\theta = 6^{\circ}$ with an inset 8 showing the corresponding 2D Fourier transform of the whole image, allowing us to 9 10 quantitatively obtain the ripple periodicity of the irradiated sample. Here the periodicity is considered as the peak-to-peak distance. As two separated spots are clearly observed in the 11 Fourier transformation, a periodicity of the wave pattern can therefore be easily deduced. This 12 periodicity was verified with the line scan taken from the same image and showing the surface 13 profile shown below Fig. 5a. From Figure 5(b) to 5(e) 3D AFM images of (100)-SrTiO₃ 14 surfaces irradiated with 92 MeV Xe are shown for fluences and angles as follow: (b) $\phi = 7 \times$ 15 10^{13} cm⁻² and $\theta = 5^{\circ}$, (c) $\phi = 1 \times 10^{14}$ cm⁻² and $\theta = 9^{\circ}$, (d) $\phi = 2 \times 10^{14}$ cm⁻² and $\theta = 21^{\circ}$, and (e) 16 $\phi = 3 \times 10^{14} \text{ cm}^{-2} \text{ and } \theta = 31^{\circ}.$ 17

From these images, we can see that the formation of the wave-like structures is indeed 18 reproducible and the ridges of the structures appear perpendicular to the direction of the ion 19 beam onto the surface (indicated by the dark arrow on the images) for all the irradiation 20 angles used in this study. It should be mentioned that the arrow does not represent the real 21 value of the angle, but is there as an indication to allow a clear visualization of the direction of 22 the beam and the distinction with an irradiation normal to the surface. Fig.5 (b) shows waves 23 like structures with a periodicity around $3 \mu m$, while in (c) for an irradiation at 9° a 24 periodicity about 6 µm is obtained. By increasing the angle of incidence towards the normal 25

to the surface just as the fluence, the ridges of these quasi-periodic patterns tend to expand in the direction perpendicular to the ion beam. As can be seen in Fig.5 (d) and (e) for an irradiation at 21° and 31°, periodicities of 16 μ m and 17 μ m are observed, respectively. This means that the more the angle decreases towards the grazing direction, the more the periodicity decreases, giving then rise to a more important quantity of ripples on the surface for grazing angle than for large angles.

7 Figure 6 represents the angle-dependence of the periodicity. Four cases are depicted, in each case two samples have around the same fluence but different angles of incidence. For small 8 angles of incidence with respect to the surface, the periodicity varies between 3 and 6 µm 9 10 while for larger angles it increases and can reach 19 µm for an irradiation at 45° which is not illustrated in this figure. This means that the periodicity of these ripples can be controlled, as 11 the ripple density on a given surface decreases with increasing the angle of irradiation towards 12 the normal to the surface. Apart from the fact that the irradiation angle affects the ripple 13 periodicity on the surface, in material depth it seems that it has a slight impact as shown by 14 the XRD patterns in Figure 7, where two samples irradiated at 11° and 6° with respect to the 15 surface with a fluence of 9×10^{13} ions/cm² are shown. The broadening along the 2 Θ axis 16 synonymous of tensile elastic deformation is slightly different; it seems to be more 17 pronounced at 11° than 6°, which may be due to a higher tensile strain in the defective 18 crystalline layer caused by a thicker irradiated layer at 11°. 19

By performing the 2D Fourier transform on our SrTiO₃ surfaces irradiated at 90° in the fluence range of 5×10^{11} to 5×10^{14} ions/cm², no periodic pattern was observed. Moreover, the irradiations were made up to an angle of 45°, and so far, there is no reorientation of the ripples (i.e. the ripples are still oriented perpendicular to the ion beam and have not become parallel to it) as observed in other reported studies for large angles [14]. In previous studies [24], the ripple width decreases as the periodicity between them increases. The width is

defined by the mean FWHM of the ripples determined from multiple cuts, and the periodicity 1 2 is the peak-to peak distance. In our case, the width of the ripples and their periodicity increase 3 as the angle of irradiation increases towards the normal to the surface. It has also been noticed that the SHI fluences required for the appearance of these ripples is much lower than the 4 fluences required in the experiments at low energies [18]. The analysis of our different 5 samples irradiated at grazing angles shows that below 4° the ripples are not clearly visible on 6 7 the AFM images. However, after performing the Fourier transform a periodicity with the appearance of two well-defined spots was observed. So for the incidence angles lower than 4° 8 the topological features are enough apparent. Effects as the ripple height could be enhanced 9 10 by high fluences for instance, but we cannot affirm this, as our data are not sufficient to 11 effectively discuss the impact of the fluence on the evolution of the periodic pattern heights. A more detailed analysis will be given in a later article, in particular on the impact of the 12 fluence after complementary irradiations and analyses. 13

Besides the 2D FFT analysis of the AFM images in order to quantify the repeatability of our 14 15 ripples, another topological aspect of these microstructures can also be studied: to gain insight into the impact of the irradiation parameters, it is possible to characterize the degree of order 16 of the surface patterns by quantifying the quality of the ripples [30]. As they form, different 17 18 types of defects appear, either as a bifurcation, where a ripple splits into two, or a discontinuous ripple. To consider an application of these periodic patterns, the control of these 19 topological defects or features is mandatory to have a short-range disorder. Figure 8 shows the 20 steps used to determine the normalized density of pattern defects from a $20 \times 20 \ \mu\text{m}^2$ AFM 21 22 image (Fig. 8(a)) using Gwydion software [28]. We first did a 2D Fourier filtering (Fig. 8(b)), 23 then a mask is created with Otsu's threshold [31], which behaves like a binary image (Fig. 8(c)). Finally, the resulting images are thinned, consisting of ripples reduced to line traces 24 with a thickness of one pixel (Fig. 8(d)). This procedure enabled us to count the total number 25

of defects in our image by considering each white pixel with more than two neighboring white 1 2 pixels or with only one neighboring white pixel as a topological defect. Then the normalized density of defects is calculated using $N_D = N \lambda^2 / A$ [30] where N is the raw number of defects, 3 λ the ripple wavelength, and A the scan area of our image. For a value of N_D = 0, the pattern is 4 considered as perfect without any defect and when $N_D = 1$ each ripple contains one defect per 5 length. This was done for the various irradiated (100)-SrTiO₃ and was then represented as a 6 function of the different angles of incidence in Figure 9. For the lowest grazing angles 7 represented here, between 5° and 11°, and for fluences below 1×10^{14} ions/cm², the 8 normalized density evolves between 0.2 and 0.6. By increasing the angle, N_D increases up to a 9 10 value that corresponds to a sample where the ripples were not well formed and with several 11 defects. We assume that this can be due either to an insufficient fluence for the evolution of the patterns into a well-defined ripple structure or that a fluence threshold has been exceeded 12 for this angle inducing thus the deformation of the ripples due to an accumulation of defects. 13 For larger angles, N_D decreases again corresponding to ripples with few defects, giving then 14 rise to well-formed quasi-periodic patterns as it can be seen in fig.5 (e) for an irradiation at 15 31° with respect to the sample surface. This agrees well with what has been observed and 16 demonstrated in previous studies, where the fluence does have an influence on the pattern 17 18 quality evolution. As described by Keller et al [32] several processes occur during the formation and the evolution of ripples, as the fluence increases the ripple length grows, 19 followed by different annealing processes inducing defect annihilation and therefore a 20 21 decrease of the normalized defect density until a certain value. This is followed by the formation of a cluster of disorder implying an increase in the defect density for higher 22 fluences [18] (which increases N_D). To confirm the impact of the fluence on single crystalline 23 SrTiO₃, irradiations at intermediate fluences are planned during a future irradiation campaign 24

in order to determine the threshold fluence necessary for the formation of these ripples 1 2 depending on the angle with a minimized amount of defects.

The surface topography of all the SrTiO₃ samples irradiated with SHI at grazing angles and 3 4 high fluences shows the formation of quasi-periodic patterns on its surfaces, herein named ripples or waves, whose periodicity evolves and strongly depends on the angle of incidence of 5 the ions. It is also worth remembering that the effect of the projectile velocity cannot be 6 7 neglected, since SHI is used with an energy of a few MeV/u, the electronic regime is predominant over most of the ion beam path, giving rise to the formation of amorphous tracks 8 for each ion impact. As the formation of these ripples strongly depends on the fluence, a 9 10 regime where the tracks overlap is mandatory. As the fluence is increased, an amorphous layer finally forms on the surface with a certain thickness that varies according to the 11 geometry of the irradiation. This could influence the height of the ripples. Moreover, the 12 effect of the energy has not been demonstrated in our study given that we irradiated with two 13 relatively close energies (72 MeV and 95 MeV) but it will be the subject of a future study 14 15 with higher energy ions.

16

4. Mechanism

In the following, the possible mechanism inducing the ripple formation on SrTiO₃ surface by 17 SHI irradiation is discussed. As detailed a bit in the introduction section, when energetic ions 18 pass through solid materials, a series of interactions and processes occur, depending on the 19 20 energy of the projectile, and therefore the loss of energy in the material. Two main processes can occur, either elastic collisions with target atoms (nuclear regime) or inelastic collisions 21 22 with target electronic (electronic regime). It gives rise to atomic displacements, displacement cascades, disorder, ionizations or electronic excitations, generating structural modifications up 23 to amorphization at the surface and near the surface of the material and well in depth, along 24

the ion path, for high energy ions. In the latter case, the electronic energy loss is the dominant 1 2 slowing down process and the trajectory of the projectile is at the beginning rather straight. 3 The energy transferred to the electrons by the incident ion is quickly transmitted to the other electrons by electron-electron interactions and then to the atoms of the lattice by electron-4 phonon interactions. This will lead to a sudden increase in temperature within a cylinder of a 5 few nanometers in diameter around the ion trajectory giving then rise to a possible melting of 6 7 this cylinder. The latter will later undergo a cooling phase by dissipating its heat to the rest of the target by thermal conductivity. On the contrary, at the end of the projected ion range, 8 nuclear collisions dominate displacement 9 giving then rise to cascades. 10 A particular attention is attached to understanding the mechanism behind the formation of the periodic structures observed at high energy and described above in the manuscript. In 11 previous studies, for thin film systems especially metal oxides such as NiO [22-23], a 12 combination of two complementary processes has been proposed. First, periodic cracking of 13 the surface normal to the ion beam direction is created due to the Grinfeld's instability [33-14 15 34]. Subsequent melting and resolidification of the material within the cylindrical region 16 create stress along the ion track [21] [35], which may induce surface instability in the deposited NiO layer. When this stress exceeds the resistance of the surface to fracture, 17 18 periodic cracks can appear in the film. It is suggested that this step is later followed by an anisotropic plastic deformation (i.e., the hammering effect) [19-21] that explains the evolution 19 of these cracks into lamellar structures. 20

It should however be emphasized that in our case the situation is different from that previously described because a single crystal is used with no thin layer deposited on the surface. Moreover, we did not notice any crack on the surface even after irradiation at high fluences, X-Ray diffraction even confirms that the material stays in an elastic strain regime. The question is therefore to understand how the extremely localized energy deposited by the

incident ions can induce the observed self-organization of the surface of a single crystal 1 2 insulator such as SrTiO₃. During SHI irradiation of SrTiO₃, the individual amorphous tracks 3 overlap as the fluence increases, this leads to the formation of an amorphous layer with a thickness of about one micrometer (owing to the grazing geometry), followed in depth by a 4 disordered crystalline layer and very deeply by the non-irradiated crystalline matrix (see 5 Fig.3). The density of amorphous materials is generally less than that of their crystalline 6 counterparts. For instance, the reported values for amorphous and crystalline SrTiO3 are 7 4.2 g cm⁻³ and 5.1 g cm⁻³, respectively [36]. For single crystals SrTiO₃ the mechanical 8 properties like Young's modulus depend on the crystal directions. One can nevertheless define 9 10 an average Young's modulus of 260-300 GPa. Regarding amorphous SrTiO₃, recent results 11 obtained by nanoindentation give a Young's modulus ranging between 190 and 210 GPa [37]. This difference for the Young's modulus between the amorphous phase and the crystal is not 12 surprising, since the former has a lower density and its structure can be considered less rigid 13 than the crystalline phase (owing to the lack of long range order). From this and the results 14 15 provided by our TEM observations, we are in a situation where we have an amorphous "soft" layer (about one micrometer thick) over a stiffer crystalline substrate. One can therefore 16 expect an expansion of the amorphous layer with respect to the original dimensions (swelling) 17 18 caused by the irradiation induced density change. However, as this amorphous layer is intimately bound to the crystalline substrate, only the dimension normal to the surface is free 19 to expand. In contrast, along the two other dimensions, the amorphous layer is restrained and 20 21 must adapt to the crystalline substrate. This may induce the formation of wrinkles at the surface in order to minimize the energy of the system. During subsequent irradiations, any 22 protrusion at the sample surface (which is already amorphous) would be subject to anisotropic 23 plastic deformation, which will decrease the dimension parallel to the direction of the beam 24 and increase those perpendicular to it. This will cause the ripples perpendicular to the 25

direction of the beam to grow. Moreover, this effect can be more efficient on the top of the
 ripples than in the valleys due to the stopping power which decreases with the traversed
 depth.

4 **5.** Conclusion

In summary, we have shown that wave-like structures can be created on the surface of SrTiO₃ 5 single crystal material by irradiation with SHI. The formation of these periodic patterns, with 6 the ridges oriented perpendicular to the ion beam direction, mainly depends on the irradiation 7 8 parameters such as the angle of incidence. Periodic patterns are observed for irradiation in 9 grazing geometry for angles up to 45° . The fluence is also important, as it must be in a regime 10 of multiple impacts where amorphization occurs. The XRD and TEM analyzes confirm the 11 amorphous nature of the surface layer on which the ripples are formed. Following AFM characterizations, we were able to extract some characteristics of these patterns like the 12 periodicity and the width of the ripples. We noticed that they increase as the angle increases 13 towards the normal to the surface, proving that the ripple density on a given area can be 14 controlled and opens the routes for custom surface structuration. A mechanism involving the 15 density change of the bombarded layer due to its amorphization followed by SHI induced 16 anisotropic plastic deformation is proposed to explain the formation of these ripples. Further 17 analyses are needed to conclude the interpretation of these processes and will be the subject of 18 19 a future publication.

20 Acknowledgements

The experiment was performed at Grand Accélérateur National d'Ions Lourds (GANIL) by means of CIRIL Interdisciplinary Platform, part of CIMAP laboratory, Caen, France. This work was partially supported by the research platform PULVECHAMP funded by the Region

- 1 Normandie, ANR funding "Investissements d'avenir" ANR-11-EQPX-0020, the FEDER, the
- 2 CNRS Federation IRMA FR 3095 and by the Region Normandie.

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1 Figures Captions :

Figure 1: (a) SEM/FEG image for (100)-SrTiO₃ irradiated with 92 MeV Xe ions at 3.7° with ~ 5 × 10⁸ ions/cm² in individual impact fluence regime. TEM cross-section images of an ion track observed for (100)-SrTiO₃ irradiated with 92 MeV Xe ions at (b) 3.7° (surface is marked with dotted line) or (c) 0.5° in individual impact fluence regime. The red and green arrows indicate the ion irradiation direction.

Figure 2: X-ray patterns for (100)-SrTiO₃ irradiated with 75 MeV 136 Xe¹⁹⁺ ions at 6° with 8 × 10¹³ ions/cm² compared to a non-irradiated sample with a probed depth of ~ 8 µm for the 9 (200) reflection.

Figure 3: Left part: TEM image of a (100)-SrTiO₃ sample irradiated at 6° with 8×13 ions/cm². The dark arrow indicates the ion beam direction (it is a guide for the eyes but it does not represent the real value of the incident angle). Right side images show selected area electron diffraction patterns (SAD) taken at different depths of the sample.

Figure 4: $50 \times 50 \ \mu m$ AFM images: (a) a non-irradiated (100)-SrTiO₃ with an inset of an AFM image of $5 \times 5 \ \mu m$ from the same surface; (b) a (100)-SrTiO₃ sample irradiated with 92 MeV Xe ions at $\theta = 7^{\circ}$ with $\phi = 1 \times 10^{14} \text{ ions/cm}^2$ (the dark arrow indicates the ion beam direction along the x,z axis, it is a guide for the eyes but it does not represent the absolute value of the incident angle).

Figure 5: AFM images of ripples on (100)-SrTiO₃ surface irradiated with 92 MeV Xe ions. At $\phi = 9 \times 10^{13}$ cm⁻² and $\theta = 6^{\circ}$ (a) with the corresponding 2D Fourier transform of the entire image inset. The size of the image is 20 × 20 µm. A line profile of the surface is also shown below this figure (the dark arrow indicates the ion beam direction, it is a guide for the eyes but it does not represent the absolute value of the incident angle). At $\phi = 7 \times 10^{13}$ cm⁻² and $\theta = 5^{\circ}$

- 1 (b), $\phi = 1 \times 10^{14} \text{ cm}^{-2}$ and $\theta = 9^{\circ}$ (c), $\phi = 2 \times 10^{14} \text{ cm}^{-2}$ and $\theta = 21^{\circ}$ (d), and $\phi = 3 \times 10^{14} \text{ cm}^{-2}$ 2 and $\theta = 31^{\circ}$ (e).
- Figure 6: Evolution of the ripple periodicity observed on (100)-SrTiO₃ surface irradiated with
 92 MeV Xe ions according to the angle of incidence for different fluences.
- 5 Figure 7: XRD patterns for the (200) reflection of (100)-SrTiO₃ samples irradiated with 92
- 6 MeV Xe ions with ~ 9×10^{13} ions/cm² at 11° (blue line) and 6° (red dotted line).
- 7 Figure 8: (a) a $20 \times 20 \ \mu m^2$ AFM image of a (100)-SrTiO₃ sample irradiated with 92 MeV
- 8 Xe ions at $\theta = 6^{\circ}$ and $\phi = 9 \times 10^{13}$ ions/cm², (b) Fourier-filtering of (a), (c) application of the
- 9 Otsu's threshold, and (d) thinning the ripples to lines.
- Figure 9: Evolution of the normalized density of pattern defects N_D as function of the
 incident angle.